

Notice of References Cited

Application/Control No.
10/050,639

Examiner
DuyVu n Deo

Applicant(s)/Patent Under
Reexamination
LEE ET AL.

Art Unit
1765

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number		Date MM-YYYY	Name	Classification
		Country Code-Number-Kind Code				
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NON-PATENT DOCUMENTS

Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)

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	U	Wolf et al., Silicon Processing for the VLSI Era, 1986, vol. 1, page 529.
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